

PROCEEDINGS OF SPIE

# ***Current Developments in Lens Design and Optical Engineering XIII***

**R. Barry Johnson  
Virendra N. Mahajan  
Simon Thibault**  
*Editors*

**13–15 August 2012  
San Diego, California, United States**

*Sponsored and Published by*  
SPIE

**Volume 8486**

Proceedings of SPIE 0277-786-786X, V.8486

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Current Developments in Lens Design and Optical Engineering XIII, edited by R. Barry Johnson,  
Virendra N. Mahajan, Simon Thibault, Proc. of SPIE Vol. 8486, 848601  
© 2012 SPIE · CCC code: 0277-786/12/\$18 · doi: 10.1117/12.2011034

Proc. of SPIE Vol. 8486 848601-1

The papers included in this volume were part of the technical conference cited on the cover and title page. Papers were selected and subject to review by the editors and conference program committee. Some conference presentations may not be available for publication. The papers published in these proceedings reflect the work and thoughts of the authors and are published herein as submitted. The publisher is not responsible for the validity of the information or for any outcomes resulting from reliance thereon.

Please use the following format to cite material from this book:

Author(s), "Title of Paper," in *Current Developments in Lens Design and Optical Engineering XIII*, edited by R. Barry Johnson, Virendra N. Mahajan, Simon Thibault, Proceedings of SPIE Vol. 8486 (SPIE, Bellingham, WA, 2012) Article CID Number.

ISSN: 0277-786X

ISBN: 9780819492036

Published by

**SPIE**

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

SPIE.org

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## **Introduction**

Our conference on Current Developments in Lens Design and Optical Engineering attracted a large number of high-quality papers that ranged from optical design and analysis to design optimization, fabrication, solid state lighting, tunable lenses, and optical thin films. Thirty-two oral papers were presented in nine sessions over a period of two-and-a-half days. Two of these papers were in the invited category. Eleven papers were discussed in a poster session. Our conference continues to be an excellent venue for presentation and discussion of a very diverse range of lens design and optical engineering research and development activities.

**R. Barry Johnson**  
**Virendra N. Mahajan**  
**Simon Thibault**

